



RCVD
11/6/2003
JL

SHEET 1 OF 1

Form PTO 1449
(Modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

231064US0

SERIAL NO.

New Application

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Maria DALKO, et al.

FILING DATE

Herewith

GROUP

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
|---------------------|----|--------------------|------|------|-------|--------------|-------------------------------|
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
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| | AK | | | | | | |
| | AL | | | | | | |
| | AM | | | | | | |
| | AN | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | DATE | COUNTRY | TRANSLATION | |
|----|----|--------------------|----------|---------|-------------|----|
| | | | | | YES | NO |
| FC | AO | 0 691 327 | 01/10/96 | Europe | | |
| FC | AP | 1 090 630 | 04/11/01 | Europe | | |
| FC | AQ | 2 798 590 | 03/23/01 | France | | xx |
| FC | AR | WO 97/37967 | 10/16/97 | WIPO | | |
| | AS | | | | | |
| | AT | | | | | |
| | AU | | | | | |
| | AV | | | | | |

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

| | | | | | | |
|------|----|--|--|--|--|--|
| /FC/ | AW | Anthony J. Shuker et al.; "The Application of High-Throughput Synthesis and Purification to the Preparation of Ethanolamines"; Tetrahedron Letters, Vol. 38, No. 35, pp. 6149-6152, 1997 | | | | |
| | AX | | | | | |
| | AY | | | | | |
| | AZ | | | | | <input type="checkbox"/> Additional References sheet(s) attached |

Examiner

/Frank Choi/

/Frank Choi/

Date Considered

01/07/2007

12/10/2007

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.